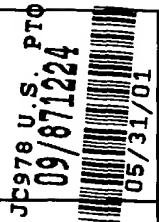


U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE



SAT
#4
2-12-01

INFORMATION DISCLOSURE STATEMENT

Docket Number
10191/1811

Application Number
~~To Be Assigned~~

09/871224

Filing Date
~~Herewith~~

5-31-01

Examiner
~~To Be Assigned~~

Olson

Art Unit
~~To Be Assigned~~

1746

Title
**DEVICE AND METHOD FOR ETCHING A
SUBSTRATE BY USING AN INDUCTIVELY
COUPLED PLASMA**

Applicant(s)
Klaus BREITSCHWERDT et al.

Assistant Commissioner
for Patents
Washington, D.C. 20231

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references (cited in the specification of the above-identified application) to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, except as otherwise indicated on the modified PTO form 1449.

Dated: **5/31/2001**

By:

Richard L. Mayer (Reg. No. 27,490)

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